

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#12 Amdt

**PATENT** 

In re application of: Kapre, et al

Attorney Docket No.: 01-721/LSI1P18

Application No.: 10/020,304

Examiner: Sefer, Ahmed N.

Filed: December 13, 2001

Group: 2826

Title: BURIED CHANNEL DEVICES AND A PROCESS FOR THEIR FABRICATION SIMULTANEOUSLY WITH SURFACE CHANNEL DEVICES TO PRODUCE TRANSISTORS AND CAPACITORS WITH MULTIPLE ELECTRICAL GATE OXIDES

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as first-class mail on July 1, 2003 in an envelope addressed to the Commissioner for Patents, Mail Stop RCE, P.O. Box 1450 Alexandria, VA 22313-1450.

Signed: Ataue Wolfan

## Amendment C

Mail Stop RCE Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

USSN: 10/020,304

In connection with the Request for Continued Examination submitted herewith, please amend the above-identified patent application as follows and consider the enclosed remarks. A listing of the claims commences on page 2. Remarks begin on page 4 of this paper.

Atty Dkt No.: LSI1P185